

RECEIVED
CENTRAL FAX CENTER

NOV 17 2003

OFFICIAL

Attorney Docket No.: F077

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPL. NO: 09/982,110

ART UNIT: 2881

APPLICANTS: Robert L. Gerlach, et al.

EXAMINER: Mary A. El Shammaa

FILING DATE: October 17, 2001

TITLE: Focused Ion Beam System

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

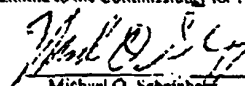
In response to the July 16, 2003 Office action, please amend the above-identified application as follows:

Amendments to the Claims are reflection in the listing of claims which begins on page 2

Remarks begin on page 8 of this paper.

CERTIFICATE OF FACSIMILE

I hereby certify that this paper or fee is being transmitted via facsimile to the Commissioner for Patents on the 17th day of November, 2003.

By: 
Name: Michael O. Scheinberg